



ITW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUNAKOSHI, Yoshirou, et al.**

Group Art Unit: 1621

Serial No.: **10/516,940**

Examiner: **PARSA, Jafar F.**

Filed: **December 15, 2004**

P.T.O. Confirmation No.: 5922

**FOR: METALLIC COPPER CATALYST FOR POLYFLUOROALKYLETHYL
IODIDE PRODUCTION AND PROCESS FOR PRODUCING
POLYFLUOROALKYLETHYL IODIDE**

REQUEST FOR STATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: June 15, 2006

Sir:

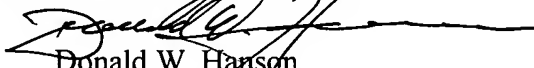
The undersigned attorney requests the status of the above-identified application.

The application was filed on **December 15, 2004** in the U.S. Patent and Trademark Office
and to date no Office Action has been received.

In the event any fees are required in connection with this paper, please charge Deposit
Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS,
HANSON & BROOKS, LLP


Donald W. Hanson
Attorney for Applicants
Reg. No. 27,133

DWH/jkw
Atty. Docket No. **040664**
Suite 1000
1725 K Street, N.W.
Washington, D.C. 20006
(202) 659-2930



23850

PATENT TRADEMARK OFFICE